



SHEET 1 OF 1

INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION

(PTO-1449)

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50212-569SERIAL NO.
10764,497APPLICANT
Manabu SHIOZAKI, et al.FILING DATE
January 27, 2004GROUP
Not yet assigned

2872

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code(s) (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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FOREIGN PATENT DOCUMENTS

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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	
TK		KASHIKO KODATE; "Development of Diffractive Optics and Future Challenges"; <u>Japan Women's Bulletin</u> , Department of Mathematical and Physical Sciences, Vol. 10; c. 2002; pp. 7-24	
TK		HENDRIK J. GERRITSEN et al.; "Rectangular Surface-Relief Transmission Gratings with a Very Large First-Order Diffraction Efficiency (~95%) for Unpolarized Light"; <u>Applied Optics</u> , Vol. 37, No. 25; c. 1998; pp. 5823 - 5829	
Y		SHUHEI TANAKA, Lecture entitled: "Glass Materials for Optical Waveguiding Nanoglass Devices", Summary of Workshop on Nanotech-Material Associated With Devices, 2002, pp 125-127, Japan.	
TK		TATSUYA HORII, "Epoch of Light Caused By Nano Glass" Nanotech Weekly, Vol. 1133, pp 6-21, 2003, Japan	
EXAMINER FAVEZ ASSAF		DATE CONSIDERED 11/4/05	

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